

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application: **Miller et al.**Serial No.: **09/863,979**Filed: **May 23, 2001**For: **Method and Apparatus for
Deposition of Porous Silica Dielectrics**§
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§Group Art Unit: **1763**Examiner: **Lund, Jeffrie Robert**Attorney Docket No.: **98-197/1D/RCE**RECEIVED
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I hereby certify this correspondence is being transmitted via
facsimile to the Commissioner for Patents, P.O. Box 1450,
Alexandria, VA 22313-1450, facsimile number (703) 872-
9306, on November 20, 2003.

By: Amelia C. Turner

Amelia C. Turner

RESPONSE TO OFFICE ACTION

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

No fees are believed to be required. If, however, any fees are required, I authorize the Commissioner to charge these fees which may be required to LSI Logic Corporation Deposit Account No. 12-2252. No extension of time is believed to be necessary. If, however, an extension of time is required, the extension is requested, and I authorize the Commissioner to charge any fees for this extension to LSI Logic Corporation Deposit Account No. 12-2252.

In response to the Office Action dated August 20, 2003, please amend the above-identified application as follows: